



do not enter LC 03/17/2008

Docket No.: 071971-0432

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Satoshi SHIBATA

RESPONSE UNDER 37 CFR 1.116

EXPEDITED PROCEDURE

Application No.: 10/557,746

Customer No.: 53080

Confirmation No.: 2300

Filed: November 21, 2005

Group Art Unit: 2813

Examiner: Crawford, Latanya N

Title: MANUFACTURING METHOD OF A SEMICONDUCTOR DEVICE

AMENDMENT UNDER 37 CFR 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the final Office Action dated November 28, 2007, having a three-month shortened statutory period for response set to expire February 28, 2008, please amend the above-identified application as follows.